	Form PTO-1595 (Rev. 03/ 01)			J.S. DEPARTMENT OF COMMERCE U.S. Patent and Trademark Office		
	OMB No. 0651-0027 (exp. 5/31/2002)	102400	322			
	To the Honorable Commissioner of Patents and Trademarks: Please record the attached original documents or copy thereof					
	Name of conveying party(ie Thomas Schafbauer (03/03/200 Ehrenwall (11/01/2002), and To	03), Andreas Von	Name and address of Name: Infineon Techn Internal Address:	ologies North America Corp		
	Additional name(s) of conveying party(i attached?	es) Yes x No	Street Address: 1730 North First Stree	PUR 24 OCE		
	3. Nature of Conveyance: X Assignment Security Agreement Other Execution Date: see Box	Merger Change of Name 1, conveying parties	City: San Jose State: CA Additional name(s) & address(es) attached:	Zip: 95112 Yes x No		
	4. Application number(s) or patent number(s):					
	If this document is being filed togethe A. Patent Application No.(s): 09/826,732	` '	ecution date of the new application B. Patent No.(s):	on is:		
	Additional numbers attached? Yes x No					
	5. Name and address of party to concerning document should be		6. Total number of applica patents involved:	tions and		
	Name: Gregory S. Gewirtz LERNER, DAVID, LITTENBERG, KRUMHOLZ & MENTLIK, LLP Street Address: 600 South Avenue West		7. Total fee (37 CFR 3.4	1) \$ 40.00		
			=	charged to deposit account charged to credit card		
	City: S Westfield N	tate: Zip: IJ 07090	8. Deposit account numb			
	9. Statement and signature. To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.					
	Gregory S. Gewirt Name of Person Sign		Signature	March 19, 2003 Date		
/	Total number of pages including cover sheet, attachments, and documents:					
03/25/2003 ECOOPER						
01 FC:8021	40.00 CH					

PATENT

REEL: 013874 FRAME: 0238

ASSIGNMENT OF UTILITY APPLICATION

Docket Number (Optional)

01P06119US (INTECH 3.0-047)

Whereas, I, Thomas Schafbauer				
55 Avenue Italie, 75013, Paris, France	_			
hereafter referred to as assignor, have with others invented certain new and useful improvements in STRUCTURE AND METHOD FOR DETERMINING EDGES OF REGIONS IN A SEMICONDUCTOR WAFER				
x for which an application for a United States Letters Patent was filed on April 5, 2001	-			
Application Number 09/826,732				
for which an application for a United States Letters Patent was executed by me on And	_ '			
Whereas, Infineon Technologies North America Corp.	_			
a corporation of <u>Delaware</u> herein referred to as "assignee" whose mailing address is				
1730 North First Street, San Jose, CA 95112 Is desirous of acquiring the entire right, title and interest in the same;	-			
is desirous or acquiring the entire right, title and interest in the same,				
NOW, THEREFORE, in consideration of the sum of One dollars (\$ 1.00), the receipt of is acknowledged, and other good and valuable consideration, I as assignor hereby sell, assign and set over assignee my entire right, title and interest for the United States of America and all other countries in and invention and the aforesaid utility patent application and all original, divisional, continuation, substitute or applications and patents applied for or granted therefor in the United States of America and all other countries aid invention, including without limitation all applications and patents for said invention claiming priority or be the aforesaid utility application pursuant to any law or treaty, and including the right to claim such priority or and the Commissioner of Patents and Trademarks is hereby authorized and requested to issue all patents improvements or resulting therefrom to said assignee herein, as assignee of the entire interest therein; a undersigned for me and my legal representatives, heirs and assigns do hereby agree and covenant without remuneration, to execute and deliver all original, divisional, continuation, reissue and other applications for Patent on said improvements and all assignments thereof to said assignee or its assigns, to communicate assignee or its representatives all facts known to the undersigned respecting said improvements, where the representative and improvements and the patent proceedings in which any of said applications or patent become involved, to sign all lawful papers, make all rightful oaths, and to do generally everything necessary assignee, its successors, assigns and nominees to obtain patent protection for said improvements in all country expenses incident to said applications to be borne and paid by said assignee.	to said to said reissue ries, for enefit of benefit on said and the further Letters to said nenever its may y to aid			
03/03/03 Manas Shaftano				
(Date) Thomas Schafbauer				
C3/03/03 (Date) Thomas Schafbauer Pougld M. Cramer Printed Name of Witness				
*Total of 3 forms are submitted				

x *Total of 3 forms are submitted.

PATENT

REEL: 013874 FRAME: 0239

ASSIGNMENT OF UTILITY APPLICATION

Docket Number (Optional)

01P06119US (INTECH 3.0-047)

Whereas, I, Andreas Von Ehrenwall			_ of				
C/o Infineon Technologies, Koenigsbrueckerstr. 180, Dresden 01099, GE	RMANY						
hereafter referred to as assignor, have with others invented certain new and usefu STRUCTURE AND METHOD FOR DETERMINING EDGES OF REGI SEMICONDUCTOR WAFER			_				
X for which an application for a United States Letters Patent was filed on	April 5, 2	2001					
Application Number 09/826,732							
for which an application for a United States Letters Patent was executed by	me on		_ ,				
for which an International Application was filed on		, as					
, designating the United States.							
And							
Whereas, Infineon Technologies North America Corp.			_				
a corporation of <u>Delaware</u> herein referred to as "assignee" whose mailing address	is						
1730 North First Street, San Jose, CA 95112			_				
Is desirous of acquiring the entire right, title and interest in the same;							
invention and the aforesaid utility patent application and all original, divisional applications and patents applied for or granted therefor in the United States of said invention, including without limitation all applications and patents for said in the aforesaid utility application pursuant to any law or treaty, and including the and the Commissioner of Patents and Trademarks is hereby authorized and re improvements or resulting therefrom to said assignee herein, as assignee of undersigned for me and my legal representatives, heirs and assigns do hereby remuneration, to execute and deliver all original, divisional, continuation, reissuration on said improvements and all assignments thereof to said assignee or assignee or its representatives all facts known to the undersigned respect requested, to testify in any interferences or other legal proceedings in which any become involved, to sign all lawful papers, make all rightful oaths, and to do gassignee, its successors, assigns and nominees to obtain patent protection for sa expenses incident to said applications to be borne and paid by said assignee.	America a vention cla right to cla quested to the entire agree and other its assigns ting said of said apenerally ev	nd all other count iming priority or be im such priority or issue all patents interest therein; a d covenant without er applications for to communicate improvements, who polications or pater verything necessar	ries, for enefit of benefit on said and the t further Letters to said henever hts may y to aid				
	eas Von Et	Elsculle nrenwall					
x *Total of 3 forms are submitted.		.,					

LD-515\

	former PTO/SB/15 (8-00) Modified LDLK&N				
ACCIONIMENT OF LITTLETY APPLICATION	Docket Number (Optional)				
ASSIGNMENT OF UTILITY APPLICATION	01P06119US (INTECH 3.0-047)				
Whereas, I, Tobias Mono	of				
15 Angelikastr. 15, Dresden, Germany 01109					
hereafter referred to as assignor, have with others invented certa STRUCTURE AND METHOD FOR DETERMINING ELSEMICONDUCTOR WAFER					
X for which an application for a United States Letters Pate	ent was filed on April 5, 2001				
Application Number 09/826,732					
for which an application for a United States Letters Patent was executed by me on					
for which an International Application was filed on, as					
, designating the United	States.				
And					
Whereas, Infineon Technologies North America Corp.					
a corporation of Delaware herein referred to as "assignee" whose	e mailing address is				
1730 North First Street, San Jose, CA 95112					
Is desirous of acquiring the entire right, title and interest in the sa	me;				
NOW, THEREFORE, in consideration of the sum of one is acknowledged, and other good and valuable consideration, is assignee my entire right, title and interest for the United State invention and the aforesaid utility patent application and all of applications and patents applied for or granted therefor in the said invention, including without limitation all applications and patents application pursuant to any law or treaty, a and the Commissioner of Patents and Trademarks is hereby a improvements or resulting therefrom to said assignee herein, undersigned for me and my legal representatives, heirs and as remuneration, to execute and deliver all original, divisional, concept assignee or its representatives all facts known to the unconcept of the said improvements and all assignments thereof to sassignee or its representatives all facts known to the unconcept of the said involved, to sign all lawful papers, make all rightful of assignee, its successors, assigns and nominees to obtain patent expenses incident to said applications to be borne and paid by said	es of America and all other countries in and to said original, divisional, continuation, substitute or reissue. United States of America and all other countries, for satents for said invention claiming priority or benefit of and including the right to claim such priority or benefit authorized and requested to issue all patents on said, as assignee of the entire interest therein; and the ssigns do hereby agree and covenant without further ontinuation, reissue and other applications for Letters said assignee or its assigns, to communicate to said dersigned respecting said improvements, whenever lings in which any of said applications or patents may aths, and to do generally everything necessary to aid at protection for said improvements in all countries, the				
10/29/2002	Tollation				

DIETER NEES
Typed Name of Witness

Date

*Total of 3 forms are submitted. Х

RECORDED: 03/24/2003

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PATENT REEL: 013874 FRAME: 0241

Tobias Mono